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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/709,412	05/04/2004	Wen-Chang Yeh	11340-US-PA	3411
31561 7590	·	PERTY OFFICE	EXAMINER	
~	JIANQ CHYUN INTELLECTUAL PROPERTY OFFICE  7 FLOOR-1, NO. 100  ROOSEVELT ROAD, SECTION 2	MONICA D		
	ROOSEVELT ROAD, SECTION 2		ART UNIT	PAPER NUMBER
TAIWAN	·			
SHORTENED STATUTORY PE	RIOD OF RESPONSE	MAIL DATE	DELIVER	Y MODE
3 MONTHS 01/24/20		01/24/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

<del></del>		Application No.	Applicant(s)			
		10/709,412	YEH, WEN-CHANG			
	Office Action Summary	Examiner	Art Unit			
		Monica D. Harrison	2813			
	The MAILING DATE of this communication	appears on the cover sheet	with the correspondence address			
Period fo			MONTH (O) OD THIDTY (OO) DAYO			
WHIC - Exter after - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR RECHEVER IS LONGER, FROM THE MAILING asions of time may be available under the provisions of 37 CF SIX (6) MONTHS from the mailing date of this communication period for reply is specified above, the maximum statutory period for reply within the set or extended period for reply will, by steply received by the Office later than three months after the red patent term adjustment. See 37 CFR 1.704(b).	G DATE OF THIS COMMUI FR 1.136(a). In no event, however, may n. eriod will apply and will expire SIX (6) M statute, cause the application to become	NICATION.  a reply be timely filed  IONTHS from the mailing date of this communication.  ABANDONED (35 U.S.C. § 133).			
Status						
1)	Responsive to communication(s) filed on 1	19 September 2006.				
2a) <u></u> □	This action is <b>FINAL</b> . 2b)⊠	This action is non-final.	•			
3)	☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
	closed in accordance with the practice und	der <i>Ex parte Quayle</i> , 1935 C	D. 11, 453 O.G. 213.			
Dispositi	on of Claims					
4) 🖂	Claim(s) 1-21 is/are pending in the applica	ation.	·			
•	4a) Of the above claim(s) <u>1-15</u> is/are withdrawn from consideration.					
5)	Claim(s) is/are allowed.					
6)🖂	Claim(s) 16-21 is/are rejected.	,	• • • • • • • • • • • • • • • • • • • •			
7)	Claim(s) is/are objected to.					
8)□	Claim(s) are subject to restriction a	nd/or election requirement.	•			
Applicati	ion Papers					
9)[]	The specification is objected to by the Exar	miner.				
• —	The drawing(s) filed on 04 May 2004 is/are		jected to by the Examiner.			
	Applicant may not request that any objection to					
	Replacement drawing sheet(s) including the co	orrection is required if the drawi	ng(s) is objected to. See 37 CFR 1.121(d).			
11)	The oath or declaration is objected to by th	e Examiner. Note the attach	ned Office Action or form PTO-152.			
Priority u	ınder 35 U.S.C. § 119		,			
12)	Acknowledgment is made of a claim for for	eign priority under 35 U.S.C	;, § 119(a)-(d) or (f).			
•	⊠ All b) ☐ Some * c) ☐ None of:					
•	1. Certified copies of the priority documents have been received.					
	2. Certified copies of the priority documents have been received in Application No					
	3. Copies of the certified copies of the	priority documents have be	en received in this National Stage			
	application from the International Bu	reau (PCT Rule 17.2(a)).	•			
* 5	See the attached detailed Office action for a	a list of the certified copies n	ot received.			
		•				
	•					
Attachmen	t(s)					
· <u>—</u>	e of References Cited (PTO-892)	· — — —	w Summary (PTO-413)			
·	e of Draftsperson's Patent Drawing Review (PTO-948 nation Disclosure Statement(s) (PTO/SB/08)		lo(s)/Mail Date of Informal Patent Application			
Paper No(s)/Mail Date						

#### **DETAILED ACTION**

#### Election/Restrictions

1. Applicant's election without traverse of Group II, claims 16-21, in the reply filed on September 19, 2006 is acknowledged. Examiner acknowledges claims 1-15 have been cancelled.

## Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 16 and 18-21 are rejected under 35 U.S.C. 102(b) as being anticipated by Tasch Jr. et al (4,409,724).

2. Regarding claim 16, Tasch Jr. et al discloses a structure of thin-film transistor (TFT), comprising: a poly-crystal semiconductor island (Figure 8, reference 14), formed on a substrate (Figure 8, reference 10), wherein the poly-crystal semiconductor island is with respect to a rectangular region having a long side and a short side (Figure 7, reference 14), wherein a plurality long-shape crystal grains from a center strip region along the direction of the long side to the long side (*crystal grains are formed by the annealing of the polycrystalline semiconductor film*); a gate insulating film, over the semiconductor island (Figure 8, reference 20); and a strip gate, located on the gate insulating film between the center grain boundary and the long side,

wherein a direction of the strip gate in along the direction of the long side (Figure 8, reference 21); and a source region (Figure 8, reference 18) and a drain region (Figure 8, reference 19) are parts of the semiconductor island (Figure 7, reference 14) at each side of the strip gate (Figure 8, reference 21).

- 3. Regarding claim 18, Tasch Jr. et al discloses wherein the semiconductor island has a saw-like periphery along the long sides (Figure 8, reference 14; saw-like may be created by the annealing of the polycrystalline layer).
- 4. Regarding claim 19, Tasch Jr. et al discloses a strip semiconductor peninsula joining to one side of the semiconductor island (Figure 8, reference 21).
- 5. Regarding claim 20, Tasch Jr. et al discloses wherein the center strip region is a center grain boundary (Figure 8, reference 21).
- 6. Regarding claim 21, Tasch Jr. et al discloses wherein the semiconductor island is used as an active island of the thin-film transistor without additional patterning (Figure 8, reference 14).

# Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim 17 is rejected under 35 U.S.C. 103(a) as being unpatentable over Tasch Jr. et al (4,409,724) in view of Ngochi et al (6,190,949 B1).

7. Tasch Jr. et al discloses all above claimed subject matter except wherein the number of the long crystal grains is determined by a ratio of the long side to the short side (claim 17).

Ngochi et al discloses wherein the number of the long crystal grains is determined by a ratio of the long side to the short side (column 8, lines 17-47).

It is obvious, at the time the invention was made, for one having ordinary skill in the art, to modify Tasch Jr. et al, with the teachings of Ngochi et al, for the purpose of forming single crystal grains in a semiconductor device.

### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Monica D. Harrison whose telephone number is 571-272-1959. The examiner can normally be reached on M-F 7:00am-3:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr. can be reached on 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Art Unit: 2813

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Monica D. Harrison AU 2813

mdh January 18, 2007

CARL WHITEHEAD, JR.
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800

1/1 /1 /1/201